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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/716,424 Confirmation No. 6953  
Applicant(s) : Il-Young KWON  
Filed : November 20, 2003  
Art Unit : 2823  
Examiner : Garcia, Joannie A.  
Entitled : METHOD FOR MANUFACTURING CAPACITOR BOTTOM  
ELECTRODE OF SEMICONDUCTOR DEVICE  
  
Attorney Refer. : 123037-05005115  
Customer No. : 43569

**LETTER TO THE OFFICIAL DRAFTSPERSON**

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

June 27, 2005

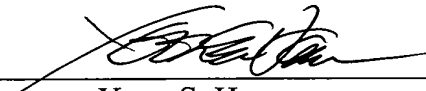
Sir:

X The informalities noted in Examiner's Amendment/Comment or in the Office action of Paper No./Mail Date 03-14-05 have been:

X Corrected on substitute sheets of Formal Drawings. (15 sheets, Figs. 1A-4G)

Respectfully submitted,

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